

IF 1753



F-9089
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Joachim MAI, et al.
Serial No. : 10/578,047
Filed : August 7, 2007
For : METHOD AND DEVICE FOR ION BEAM
PROCESSING OF SURFACES
Group Art Unit : UNKNOWN
Examiner : UNKNOWN

Certificate of Mailing Under 37 CFR 1.8

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INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is an Information Disclosure Citation together with
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Respectfully submitted,

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